

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

JIN-XING LI ET AL.

Serial No.: 10/528,765

Filed: December 1, 2006

For: TWO LAYER LTO TEMPERATURE OXIDE
CKSIDE SEAL FOR A WAFER

Group Art Unit: 1794

Examiner: Jonathan C. Langman

Attorney Docket No.: WSAG 0107 PUSA

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 23, 2010, please amend the above-identified application as follows: